	Application No.	Applicant(s)	
Notice of Allowability	10/074,855	PERRIN, MARK A.	
	Examiner	Art Unit	
	Rodney G. McDonald	1753	
The MAILING DATE of this communication appeall claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap) or other appropriate communication (IGHTS. This application is subject to	plication. If not included will be mailed in due co	urse. THIS
1. \boxtimes This communication is responsive to <u>Amendment filed 1-1</u>	<u>5-04</u> .		
2. X The allowed claim(s) is/are 2-17,19-29 and 31-47.			
3. 🖾 The drawings filed on 11 February 2002 are accepted by t	he Examiner.		
 4. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority do International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	e been received. e been received in Application No		n from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requi	rements
 A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give 			TCE OF
 CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner' Paper No./Mail Date 	son's Patent Drawing Review(PTO-	,	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t			ck) of
 DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT 			e the
Attachment(s) 1. □ Notice of References Cited (PTO-892) 2. □ Notice of Draftperson's Patent Drawing Review (PTO-948)	5. ☐ Notice of Informal P 6. ☐ Interview Summary	(PTO-413),	52)
3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0	Paper No./Mail Dat 08), 7. ☐ Examiner's Amendn		
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examiner's Stateme 9. □ Other		

Rodney G. McDonald Primary Examiner Art Unit: 1753

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REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance:

Claims 2-17 are allowable over the prior art of record because the prior art of record does not teach a cathode defining a central axis exterior to the cathode and the cathode interior sputtered surface defining a central interior axis which is ring-shaped and forms a closed loop around the exterior central axis, the anode being ring-shaped and defining a ring-shaped center axis coaxially aligned with the cathode central interior axis.

Claims 19-26 are allowable over the prior art of record because the prior art of record does not teach the toroidal cathode with the plurality of passageways positioned between the exterior surface and the sputtering surface and oriented to permit ionized sputtered deposition material discharged from the plasma generation region, to pass through the cathode and to the exterior of the cathode and the anode positioned within the vessel adjacent to the plasma generation region and facing the cathode interior sputtering surface.

Claim 27 is allowable over the prior art of record because the prior art of record does not teach the claimed subject matter including the cathode having a plurality of passageways positioned between the exterior surface and the sputtering surface and oriented to permit ionized sputtered deposition material discharge to the exterior of the cathode.

Claims 28 and 29 are allowable over the prior art of record because the prior art of record does not teach the claimed subjected matter including the cathode having a

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plurality of passageways positioned between the exterior surface and the sputtering surface and oriented to permit ionized sputtered deposition material discharge to the exterior of the cathode.

Claims 31-37 are indicated as being allowable over the prior art of record because the prior art of record does not teach the cathode having a plurality of apertures positioned to discharge sputtered deposition material from the interior of the cathode, the method further comprising positioning the semiconductor workpiece within the vessel interior to face the sputtering surface apertures to receive sputtered deposition material form the interior of the cathode.

Claims 38-45 are allowable over the prior art of record because the prior art of record does not teach the method as claimed including directing ionized deposition material through a plurality of apertures in the cathode to the exterior of the cathode and onto the substrate.

Claim 46 is allowable over the prior art of record because the prior art of record does not teach the subject matter as claimed including the plurality of apertures in the cathode in combination with the torus-shaped magnetic field.

Claim 47 is allowable over the prior art of record because the prior art of record does not teach the claimed subject matter including the plurality of apertures in the cathode in combination with the torus-shaped magnetic field.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably

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accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Rodney G. McDonald whose telephone number is 571-272-1340. The examiner can normally be reached on M- Th with Every other Friday off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nam X. Nguyen can be reached on 571-272-1342. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Twhey & McDonald Rodney G. McDonald Primary Examiner Art Unit 1753

RM February 20, 2004